Full Length Research Paper

# Hardness-improvement of titanium using mixture gases

# Kittichai Sopunna<sup>1</sup>\* and Somchai Thongtem<sup>2</sup>

<sup>1</sup>Department of Physics, Faculty of Science and Technology, Sakon Nakhon Rajabhat University, Sakon Nakhon 47000, Thailand.

<sup>2</sup>Department of Physics, Faculty of Science, Chiang Mai University, Chiang Mai 50200, Thailand.

Accepted 23 November, 2012

Hardness of 99.7% titanium was improved in acetylene-ammonia mixtures at 1,250°C for 2 h. The flow rate of acetylene was set constantly at 0.4 cm<sup>3</sup>s<sup>-1</sup>, but those of ammonia were varied over the range of 0 to 12 cm<sup>3</sup>s<sup>-1</sup>. By using an X-ray diffractometer (XRD) and an energy dispersive X-ray (EDX) analyzer, TiC, TiN, TiC<sub>0.7</sub>N<sub>0.3</sub>, and TiC<sub>0.3</sub>N<sub>0.7</sub> phases with the corresponding elements were detected. Knoop hardness (HK) of the sample was at the highest when it was processed in only acetylene. Their hardness values were decreased, but their surfaces became rougher, due to the increase of ammonia flow rates.

**Key words:** TiC, TiN, TiC<sub>0.7</sub>N<sub>0.3</sub>, TiC<sub>0.3</sub>N<sub>0.7</sub>, Knoop hardness.

# INTRODUCTION

Titanium and its alloys are now vastly expanding into many field, such as aeronautical and chemical industries, marine. sports and leisure power generation, transportation, and biomedical devices, due to their high strength and excellent corrosion resistance, low density, high strength-to-weight ratio, low modulus and good biocompatibility. However, titanium and its alloys with low hardness usually have poor wear resistance and high friction coefficient, which limits their application in engineering (Guo et al., 2011). Some titanium implants are intended for long term or permanent location, for example, as orthopaedic joint prostheses. A clinical problem sometimes encountered with titanium implants and their abutments is that they are relatively soft and easy to damage. The addition of thin hard coating to the surface of titanium might overcome those problems, that is. to protect titanium against oxidation and to improve surface hardness. Therefore, continuous research had been directed towards surface modification of titanium (Ferro et al., 2008). Research in the field of advanced ceramics had focused on the exploration of new routes to produce non-oxide materials, such as carbides, nitrides, borides, and sulfides (Aghababazadeh et al., 2007).

Among transition metals, titanium carbide, and nitride may be used for improving the poor surface properties

due to their high hardness, wear resistance and chemical inertness (Leparoux et al., 2008). In addition, titanium carbonitride have been successfully introduced in the metal cutting industry (Jun et al., 2009). Surface coatings of titanium nitride, carbide, and carbonitride can be made by chemical vapor deposition (CVD), physical vapor deposition (PVD), anodizing, plasma and laser nitriding, and thermal oxidation and ion implantation (Jin et al., 2009). The CVD and PVD of titanium are rather expensive. They need high vacuum systems and toxic chemicals. Titanium carbide, nitride, and carbonitride can be formed by direct metal-gas reaction which is an inexpensive and non-toxic process. The purpose of the present research is to improve hardness of titanium using the simple process which is benign to environment. It can be done on a large scale as well.

#### MATERIALS AND METHODS

Samples were prepared from titanium rod (99.7%) with the impurities as follows: Fe: 0.05 at%, C: 0.05 at%, N: 0.05 at%, O: 0.05 at%, and H: 0.015 at%. The rod was cut into the disks with about 20 mm diameter and 1 to 2 mm thick. The disks were ground with silicon carbide (SiC) papers and polish with 0.3  $\mu$ m alumina powder, and then they were cleaned with alcohol. Each of them was put in a high temperature reaction chamber made of quartz as shown in Figure 1. The air was removed by evacuation to 17.33 kPa absolute pressure, and purified argon was slowly fed into the chamber. The process was repeated ten times. The residual content of oxygen in the chamber before starting the reaction was

<sup>\*</sup>Corresponding author. E-mail: ksopunna@yahoo.com.

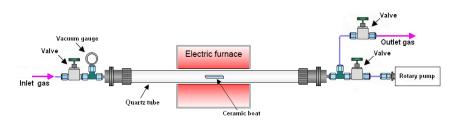
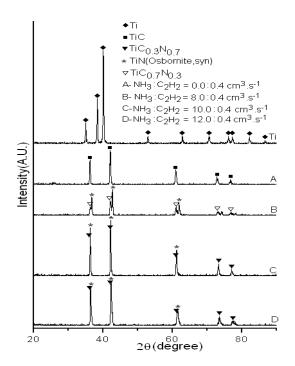


Figure 1. High temperature reaction chamber.



**Figure 2.** XRD spectra of Ti before and after processing at 1,250°C for 2 h.

calculated using the equation of state of an ideal gas and 20 volume % O<sub>2</sub> in ambient atmosphere, and it was found to be not more than 5 ppb. Each of the samples were heated in 10 cm<sup>3</sup>s<sup>-1</sup> argon until the test temperature was obtained. Then 0.4 cm<sup>3</sup>s<sup>-1</sup> acetylene and 0, 8, 10 and 12 cm<sup>3</sup>s<sup>-1</sup> ammonia were fed into the chamber. The process proceeded at 1,250°C for 2 h. At the end of the process, the furnace, ammonia, and acetylene were turned off. The samples were cooled down to room temperature and brought for further analysis. The samples was measured ten times using 5 s dwelling time and 50 gf load for a Knoop micro-hardness tester (MXT- $\alpha$ 7 Matsuzawa Seiki), X-ray diffractometer [(XRD) XRD BRUKER AXS company series D8 ADVANCE] in combination with JCPDS software (Powder Diffract. File, 2001), and SEM equipped with EDX (Jeol : JSM-6335F).

#### **RESULTS AND DISCUSSION**

#### X-ray diffraction

XRD patterns in Figure 2 showed the detection phases of

Ti, TiC, TiN, TiC<sub>0.7</sub>N<sub>0.3</sub>, and TiC<sub>0.3</sub>N<sub>0.7</sub>. Before processing, only Ti was detected (JCPDS number 44-1294). TiC, TiN, TiC<sub>0.7</sub>N<sub>0.3</sub>, and TiC<sub>0.3</sub>N<sub>0.7</sub> were produced in the mixture of acetylene and ammonia gases at 1,250°C for 2 h. At NH<sub>3</sub>:C<sub>2</sub>H<sub>2</sub> = 0:0.4, only TiC phase was detected (JCPDS number 02-1179). At NH<sub>3</sub>:C<sub>2</sub>H<sub>2</sub> = 8:0.4, TiN and TiC<sub>0.7</sub>N<sub>0.3</sub> phases were detected (JCPDS numbers 06-0642 for TiN, and 42-1489 for TiC<sub>0.7</sub>N<sub>0.3</sub>) (Zhou et al., 2009). When NH<sub>3</sub> flow rates were increased to 10 and 12 cm<sup>3</sup>s<sup>-1</sup>, TiN and TiC<sub>0.3</sub>N<sub>0.7</sub> phases were detected (JCPDS number 42-1488 for TiC<sub>0.3</sub>N<sub>0.7</sub>) (Xiang et al., 2009). At NH<sub>3</sub>:C<sub>2</sub>H<sub>2</sub> = 0:0.4, Ti reacted with C<sub>2</sub>H<sub>2</sub> to form TiC by the reaction:

 $2\text{Ti}(s) + C_2H_2(g) \rightarrow 2\text{TiC}(s) + H_2(g)$ 

TiC(s) deposited on the titanium surfaces, and  $H_2(g)$  and residual of  $C_2H_2(g)$  were drained off into the ambient atmosphere (Sopunna et al., 2004).

At NH<sub>3</sub>:C<sub>2</sub>H<sub>2</sub> = 8:0.4, NH<sub>3</sub> was added to the C<sub>2</sub>H<sub>2</sub> gas system, NH<sub>3</sub> and C<sub>2</sub>H<sub>2</sub> reacted with Ti to form nitride and carbonitride phases as explained below. At a temperature of 1,250°C, TiN ( $\Delta G_{TiN} = -195 \text{ kJ.mol}^{-1}$ ) is a little more thermodynamically stable than TiC ( $\Delta G_{TiC} = -167 \text{ kJ.mol}^{-1}$ ) (Wicks and Block, 1963). At this stage, Ti reacted with NH<sub>3</sub> to produce TiN (Sopunna et al., 2006) by the reaction:

 $Ti(s) + NH_3(g) \rightarrow TiN(s) + 1.5H_2(g)$ 

Due to the equilibrium of Ti, NH<sub>3</sub> and C<sub>2</sub>H<sub>2</sub>, TiC<sub>0.7</sub>N<sub>0.3</sub> was produced and detected as well. In the same case, at NH<sub>3</sub>:C<sub>2</sub>H<sub>2</sub> = 10 and 12:0.4, NH<sub>3</sub> was added to increase the ratio of N atom more than that of the C atom.

#### Knoop hardness (HK)

HK average value was calculated and shown in Figure 3. HK value of the substrate before processing was  $136.8 \pm 12.4 \text{ kgf.mm}^2$ . For the present research, HK was successfully improved by the carburization and carbonitridation. It was decreased with the increase in the NH<sub>3</sub> flow rates. At NH<sub>3</sub>:C<sub>2</sub>H<sub>2</sub> = 0:0.4, HK value of the sample was at maximum at 465.0 ± 33.2 kgf.mm<sup>-2</sup> (3.4 times of the substrate), due to TiC formation on its surface. This shows that TiC played the role in improving

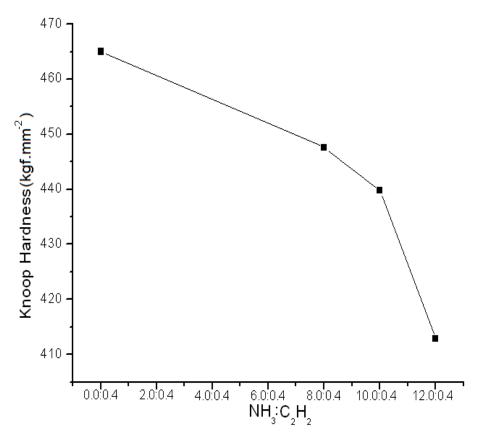


Figure 3. KH of titanium at different flow rate ratios of NH<sub>3</sub> to C<sub>2</sub>H<sub>2</sub>.

hardness of the substrate (Zhang et al., 2006).

When NH<sub>3</sub> flow rates was added and gradually increased from 0 to 12 cm<sup>3</sup>s<sup>-1</sup>, HK values were parabolically decreased with an increase in the NH<sub>3</sub> flow rates. It shows that hardness of the samples was controlled by the formation of new phases deposited on the substrates. Therefore, HK values were controlled by the flow rate of NH<sub>3</sub> gas, which led to different deposited phases on the substrates (Rebelo de Figueiredo et al., 2008).

### Energy dispersive x-ray (EDX)

By using EDX, elemental spectra of the samples before and after processing at  $1,250^{\circ}$ C for 2 h are shown in Figure 4. Before processing, only Ti was detected. After processing in C<sub>2</sub>H<sub>2</sub>, Ti, and C were detected (Liu et al., 2008). When N was added to the system, additional N was detected (Yang et al., 2008). H is a light element; therefore, it was not detected.

#### Scanning electron microscope (SEM)

SEM micrographs for as received titanium and the

titanium coated at 1,250°C for 2 h are shown in Figures 5a to e. The micrographs shows the difference between a plain surface of as received and a rough surface of the titanium coated at 1,250°C for 2 h resulting from the formation of the new phase, which could be TiN, TiC,  $\text{TiC}_{0.7}N_{0.3}$ , and  $\text{TiC}_{0.3}N_{0.7}$ . The layers are irregular showing that the reactive gases reacted with titanium. The reaction leads to surface roughness which reflects their tribological properties. It is worth noting that surface roughness was increased with the increase in the ammonia flow rates. At this stage, more products were deposited on the substrates.

#### Conclusions

Hardness of Ti was successfully improved by the 1,250°C processing in acetylene and ammonia mixtures ranging from  $NH_3:C_2H_2$  ratios of 0:0.4 to 12:0.4 for 2 h. The maximum HK value of the sample was 3.4 times of the substrate, when it was processed in 0.4 cm<sup>3</sup>s<sup>-1</sup> C<sub>2</sub>H<sub>2</sub>. HK values were decreased with the increase of ammonia flow rates. It was caused by the formation of carbonitrides analyzed using XRD and EDX. SEM micrographs showed that their surfaces were covered with the deposited phases of nitride, carbide, and carbonitrides

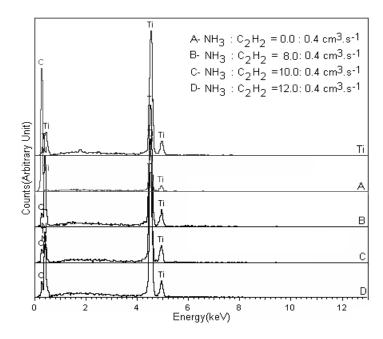
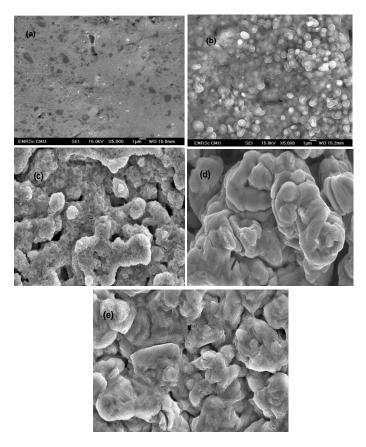


Figure 4. EDX spectra of as-received Ti and Ti with 1,250°C and 2 h processing in  $NH_3:C_2H_2$  ratios of 0:0.4, 8:0.4, 10:0.4, and 12:0.4, respectively.



**Figure 5.** SEM micrographs of a: as received Ti, and b to e: Ti with 1,250°C and 2 h processing in  $NH_3:C_2H_2$  ratios of 0:0.4, 8:0.4, 10:0.4, and 12:0.4, respectively.

reflecting the surface properties.

## ACKNOWLEDGEMENTS

We are very grateful to the Thailand Research Fund (TRF), Bangkok, for funding the research, to Sakon Nakhon Rajabhat University, and Department of Physics, Faculty of Science, Chiang Mai University, for providing the research facilities.

#### REFERENCES

- Aghababazadeh R, Mirhabibi AR, Rand B, Banijamali S, Pourasad J, Ghahari M (2007). Synthesis and characterization of nanocrystalline titanium nitride powder from rutile and anatase as precursors. Surf. Sci. 13(601):2881-2885.
- Ferro D, Rau JV, Rossi Albertini V, Generosi A, Teghil R, Barinov SM (2008). Pulsed laser deposited hard TiC, ZrC, HfC and TaC films on titanium: Hardness and an energy-dispersive X-ray diffraction study. Surf. Coat. Technol. 8(202):1455-1461.
- Guo C, Zhou J, Zhao J, Guo B, Yu Y, Zhou H, Chen J (2011). Microstructure and friction and wear behavior of laser boronizing composite coatings on titanium substrate. Appl. Surf. Sci. 9(257):4398-4405.
- Jin Q, Xue W, Li X, Zhu Q, Wu X (2009). Al<sub>2</sub>O<sub>3</sub> coating fabricated on titanium by cathodic microarc electrodeposition. J. Alloys Comp. 2(476):356-359.
- Jun W, Ying L, Ping Z, Jiancai P, Jinwen Y, Minjing T (2009). Effect of WC on the microstructure and mechanical properties in the Ti(C0.7N0.3)-xWC-Mo2C-(Co,Ni) system. Int. J. Refract. Met. Hard Mater. 6(27):9-13.
- Leparoux M, Kihn Y, Paris S, Schreuders C (2008). Microstructure analysis of RF plasma synthesized TiCN nanopowders. Int. J. Refract. Met. Hard Mater. 4(26):277-285.

- Liu N, Liu X, Zhang X, Zhu L (2008). Effect of carbon content on the microstructure and mechanical properties of superfine Ti(C, N)-based cermets. Mater. Charact. 10(59):1440-1446.
- Powder Diffract File (2001). JCPDS Internat. Centre Diffract. Data, PA 19073-3273. U.S.A.
- Rebelo de Figueiredo M, Neidhardt J, Kaindl R, Reiter A, Tessadri R, Mitterer C (2008). Formation mechanisms of low-friction tribo-layers on arc-evaporated TiC1-xNx hard coatings. Wear. 3-4(265):525-532.
- Sopunna K, Thongtem T, McNallan M, Thongtem S (2004). Surface modification of the γ-TiAl alloys by the nitridation. Surf. Sci. 2(566-568):810-815.
- Sopunna K, Thongtem T, McNallan M, Thongtem S (2006). Formation of titanium nitride on c-TiAl alloys by direct metal-gas reaction. J. Mater. Sci. 14(41):4654-4662.
- Wicks CE, Block FE (1963). Therm. Prop. 65 Elements-Their Oxides, Halides, Carbides and Nitrides. U.S. Gov. Print. Office, Washington.
- Xiang DP, Liu Y, Tu MJ, Li YY, Chen WP (2009). Synthesis of nano Ti(C,N) powder by mechanical activation and subsequent carbothermal reduction-nitridation reaction. Int. J. Refract. Met. Hard Mater. 1(27):111-114.
- Yang K, Yu S, Li Y, Li C (2008). Effect of carbonitride precipitates on the abrasive wear behaviour of hardfacing alloy. Appl. Surf. Sci. 16(254):5023-5027.
- Zhang H, Yan J, Zhang X, Tang S (2006). Properties of titanium carbonitride matrix cermets. J. Refract. Met. Hard Mater. 3(24):236-239.
- Zhou S, Zhou W, Xiong W (2009). Microstructure and properties of the cermets based on Ti(C,N). Int. J. Refract. Met. Hard Mater. 1(27):26-32.